

Notice of References Cited	Application/Control No. 10/697,161		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Pierre-Louis Desir		Art Unit 2681	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0120494	06-2004	Jiang et al.	379/210.01
*	B	US-6,574,335	06-2003	Kalmanek et al.	379/386
	C	US-			
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	F	US-			
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FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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